[TS03T4]

Nanomanufacturing and Metrology Technologies 4

Date & Time	July 9(Thu.), 2026 / 14:00–15:30
Place	Room 209B
Session Chair(s)	Prof. Jeong Hwan Kim (Hanbat National University)

TS03T4_I_1 ***Invited** 14:00–14:30

Mechanistic Understanding of How Ultrathin Oxides Stabilize Perovskite Oxide Electrodes at High Temperatures

Min Hwan Lee
(University of California, Merced)

TS03T4_I_2 ***Invited** 14:30–15:00

Customizable, Skin-Like Electronics based on Additive Manufacturing

Byeongmoon Lee
(Daegu Gyeongbuk Institute of Science and Technology)

TS03T4_I_3 ***Invited** 15:00–15:30

Plasmonic Photothermal Printing and Lossless Colored Radiative Cooling

Dangyuan Lei
(City University of Hong Kong)